

<b>Notice of References Cited</b>	Application/Control No. 10/606,965	Applicant(s)/Patent Under Reexamination HWANG, GAN LIN	
	Examiner Rebecca M. Stadler	Art Unit 1754	Page 1 of 1

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*	B	US-5,919,429	07-1999	Tanaka et al.	423/445B
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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